Application/Control No. O9/747,779 Applicant(s)/Patent Under Reexamination KIM, HONG KOO Examiner Marcos D. Pizarro-Crespo Applicant(s)/Patent Under Reexamination KIM, HONG KOO Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-	101101-1111		
	В	US-			
	С	US-			
	D	US-			-
	E	US-			
	F	US-			
	G	US-			
	Н	US-			
	-	US-			
	J	US-			
	к	US-			
	Ļ	US-			
	м	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	s				-	
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U	Richard C. Jaeger; Volume V Introduction to Microelectronic Fabrication; Addison-Wesley Publishing Company; Reading, Massachusetts, 1993, pp.41-42					
	٧						
	w						
	х						

"A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.